

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Shuji HAHAKURA, et al.  
Title: METHOD OF PRODUCING  
OXIDE SUPERCONDUCTING  
FILM (AS AMENDED)  
Appl. No.: 10/511,268  
International Filing Date: 4/17/2003  
371(c) Date:  
Examiner: Brian K. Talbot  
Art Unit: 1792  
Confirmation Number: 6578

**AMENDMENT AND REPLY UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Final Office Action dated August 14, 2008, concerning the above-referenced patent application, making October 14, 2008, two-months from the mailing date. Accordingly, the response is timely filed within the advisory period.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 5 of this document.

Please amend the application as follows: